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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. 10/075,193
Filing Date February 13, 2002
Inventor Shenlin Chen et al.
Assignee Micron Technology, Inc.
Group Art Unit 2813
priority Examiner Y. Huynh
Attorney Docket No. MI22-1927
Title: Methods of Forming a Capacitor Structure

Assistant Commissioner for Patents
Washington, D.C. 20231

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR 1.8

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1. Certificate of Facsimile Transmission
2. Information Disclosure Statement w/PTO-1449 and copy of cited reference

Dated: May 1, 2002

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INFORMATION DISCLOSURE STATEMENT
References -See Attached Form PTO-1449

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449, copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of the referenced art is respectfully requested.

This Information Disclosure Statement is being filed within three months of the filing date of the application or before the mailing date of a first Office Action, whichever occurs last. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925.

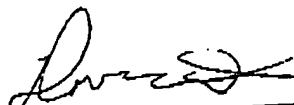
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Respectfully submitted,

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Dated: 5/1/02

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